



503.39581X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): T. USUI, et al
Serial No.: 09/788,629
Filed: February 16, 2001
For: PROCESS MONITORING METHODS IN A PLASMA
PROCESSING APPARATUS, MONITORING UNITS, AND A
SAMPLE PROCESSING METHOD USING THE MONITORING
UNITS
Group: 2812
Examiner:

PROPOSED AMENDMENT TO THE DRAWINGS

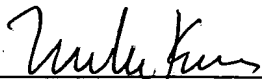
Commissioner for Patents
Washington, D.C. 20231

Sir:

It is proposed that the drawings in the above-identified application be amended in accordance with the attached red-lined print, and approval of these drawing corrections is respectfully requested at this time.

Upon receipt of the approval of the amendment to the drawings and receipt of the official Notice of Allowance, the drawing amendments will be effected in accordance with the new procedures set forth in 1017 OG 4.

Respectfully submitted,


Melvin Kraus
Registration No. 22,466
ANTONELLI, TERRY, STOUT & KRAUS, LLP

DRA/MK/cee
Attachment(s)
(703) 312-6600

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FIG. 25A

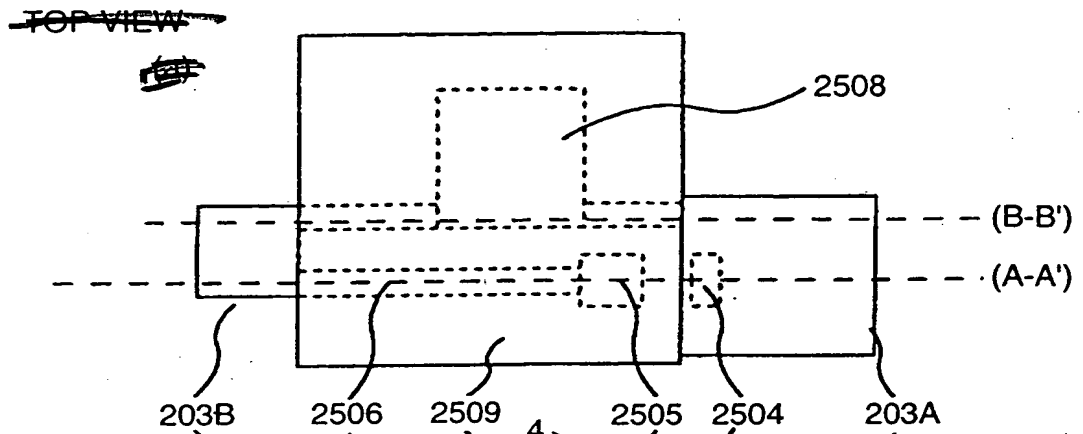


FIG. 25B

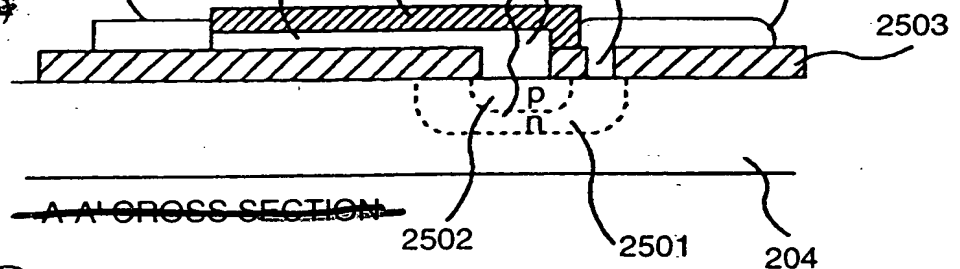
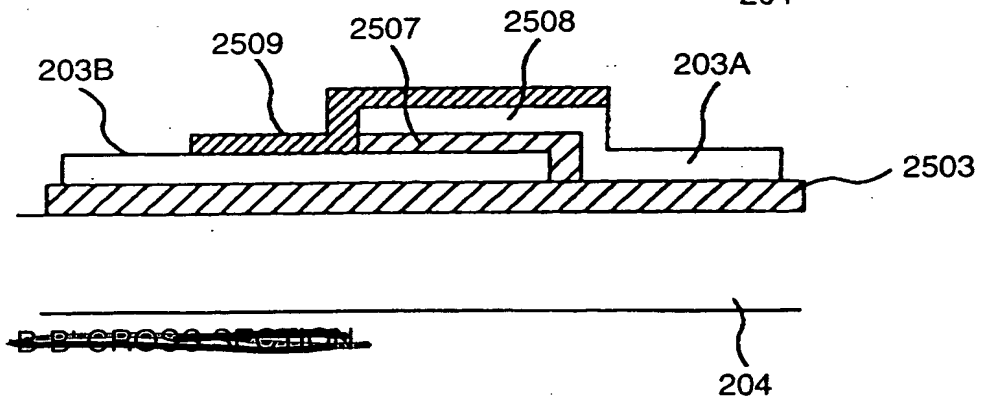


FIG. 25C



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